

FORM PTO-1449	Atty. Docket No.: I69.12-0556	Application No.: 10/674,173
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		First Named Inventor: Kalman Pelhos et al.
	Filing Date: September 29, 2003	Group Art: 1773

U.S. PATENT DOCUMENTS

Examiner Initials	Document No.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents
Hl	AA US2003/0019745	01-30-2003	Wang et al.
	AB		

FOREIGN PATENT DOCUMENTS

		Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Translation Yes No
Hl	AC	EP05280473	02-05-1995	Sony Corp.	YES
Hl	AD	EP08298096	10-21-1996	Ricoh Co Ltd.	YES
Hl	AE	EP06131571	12-01-1996	Hitachi LTD.	YES

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Hl	AF	PCT/US03/30489, <i>Notification of Transmittal of the International Search Report or the Declaration</i> , August 2004, pages 1-3.
Hl	AG	PCT/US03/30489, <i>International Search Report</i> , August 2004, pages 1-4.
Hl	AH	McMichael et al., <i>Strong Anisotropy in Thin Magnetic Films Deposited on Obliquely Sputtered Ta Underlayers</i> , November 2000, pages 5296-5299.

EXAMINER:

DATE CONSIDERED:

12/9/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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